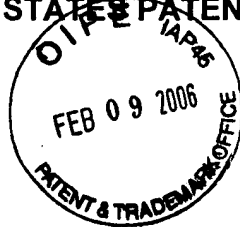


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of
An L. Steegen, et al.



Docket No. P27153

Serial No.: 10/605,906

Group Art Unit: No. 2813

Filed: November 05, 2003

Examiner: Stephen Smoot

For: **METHOD AND STRUCTURE FOR FORMING STRAINED Si FOR CMOS
DEVICES**

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop Amendment
Randolph Building
401 Dulany Street
Alexandria, VA 22314

02/10/2006 SZEWDIE1 00000065 090458 10605906

01 FC:1806 180.00 DA

Sir :

In accordance with the duty of disclosure under 37 C.F.R. §§ 1.56 and 1.97, and supplemental to the Information Disclosure Statement (IDS) filed on November 5, 2003, and Supplemental IDS filed on August 23, 2005, Applicants hereby call the following to the Examiner's attention.

The following documents were cited in an International Search Report conducted in International Application No. PCT/US04/37049, which is a counterpart of the above-captioned application. In particular, the International Examiner cited:

- (1) U.S. Patent Application Publication No. 2002/0086472, published July 4, 2002;
- (2) U.S. Patent No. 6,825,086, issued November 30, 2004;
- (3) U.S. Patent No. 6,891,192, issued May 10, 2005;
- (4) U.S. Patent Application Publication No. 2001/0003364, published June 14, 2001;
- (5) U.S. Patent No. 6,703,293, issued March 9, 2004;
- (6) U.S. Patent Application Publication No. 2003/0087492, published May 8, 2003.

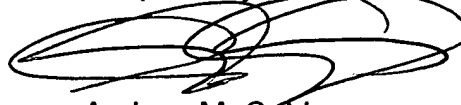
Moreover, a copy of the International Search Report is submitted herewith. However, further to the U.S. Patent and Trademark Office's decision to waive the requirement under 37 C.F.R. § 1.98 (a)(2)(i), copies of the U.S. patents and U.S. published patent applications are not enclosed herewith. However, if any copies are needed, the Examiner is respectfully requested to contact the undersigned.

Applicants respectfully request that the Examiner consider the materials cited and indicate such consideration by appropriately initialing the enclosed PTO-1449 Form and including a copy of the initialed form in the next official communication.

Applicants note that this Information Disclosure Statement is being filed after receipt of the first action on the merits from the U.S. Patent and Trademark Office and prior to the mailing date of either a final rejection under 37 C.F.R. 1.113 or a Notice of Allowance under 37 C.F.R. 1.311. Accordingly, Applicants hereby authorize the Commissioner to charge the amount of \$ 180.00 and any fees necessary to ensure consideration of the documents cited herein to International Business Machines Deposit Account No. 09-0458.

Should there be any questions concerning this application, the Examiner is invited to contact the undersigned at the below listed telephone number.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Andrew M. Calderon', is written over a circular stamp or seal.

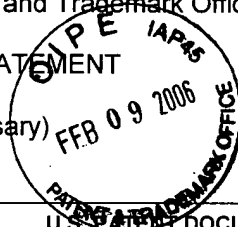
Andrew M. Calderon
Registration No. 38,093

January 31, 2006
Greenblum & Bernstein, P.L.C.
1950 Roland Clarke Place
Reston, Virginia 20191
Telephone: 703-716-1191
Facsimile: 703-716-1180

FORM PTO-1449

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket No.
P27153Application No.
10/605,906INFORMATION DISCLOSURE STATEMENT
BY APPLICANT

(Use several sheets if necessary)

Applicant
An L Steegen, et al.Filing Date
November 05, 2003Group
2813

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	2003	0 0 8 6 4 7 2	07/04/02	ROBERDS et al.			
		6 8 2 5 0 8 6	11/30/04	LEE et al.			
		6 8 9 1 1 9 2	05/10/05	CHEN et al.			
	2001	0 0 0 3 3 6 4	06/14/01	SUGAWARA et al.			
		6 7 0 3 2 9 3	03/09/04	TWEET et al.			
	2003	0 0 8 7 4 9 2	05/08/03	LEE et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.